

Optical microscope, Raman spectroscopy, and Photoluminescence measurement in two-dimensional (2D) materials

——— Youqiang

Contents

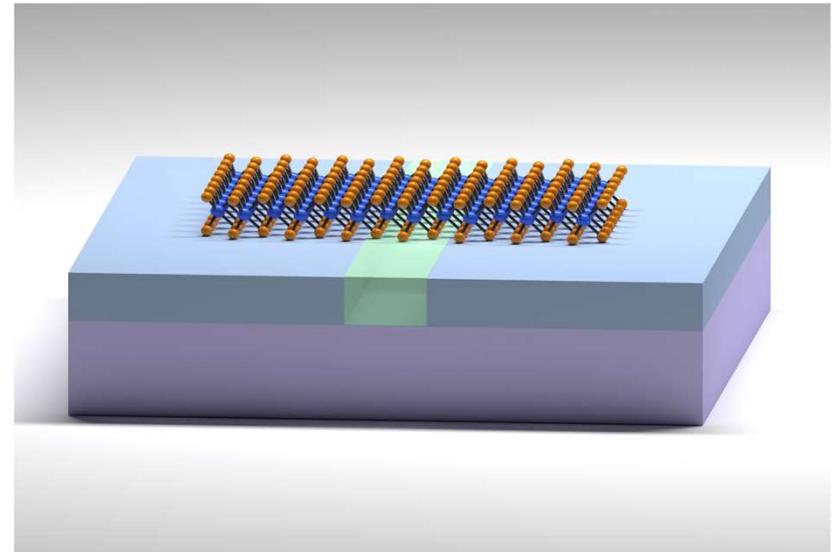
Theory

- Optical microscope
- Raman spectroscopy
- Photoluminescence measurement

Measurement setup and sources of the uncertainty

**No details about principles
and equations**

**But some useful information
on how to apply them in 2d
materials**



2d materials on a substrate

A? Background

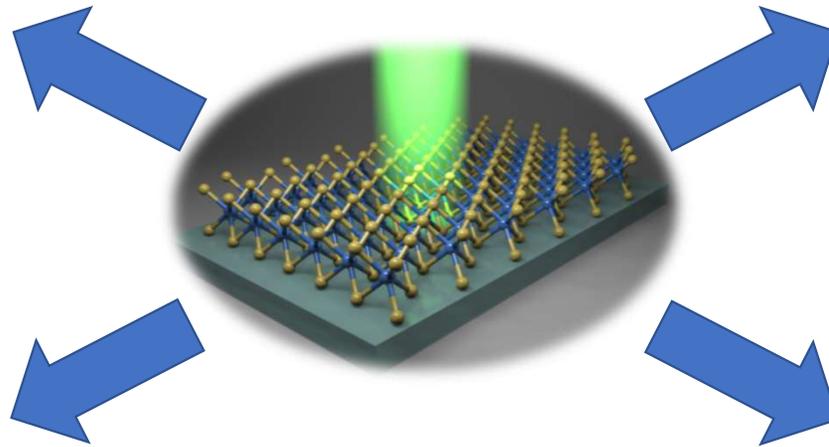
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Emission

- ★ Photoluminescence
- ★ Raman spectroscopy
- UV photoelectron spectroscopy

Reflection

- ★ Optical microscope
- Reflection spectroscopy



Absorption

- Photoconductance
- Photoelectron spectroscopy

Transmission

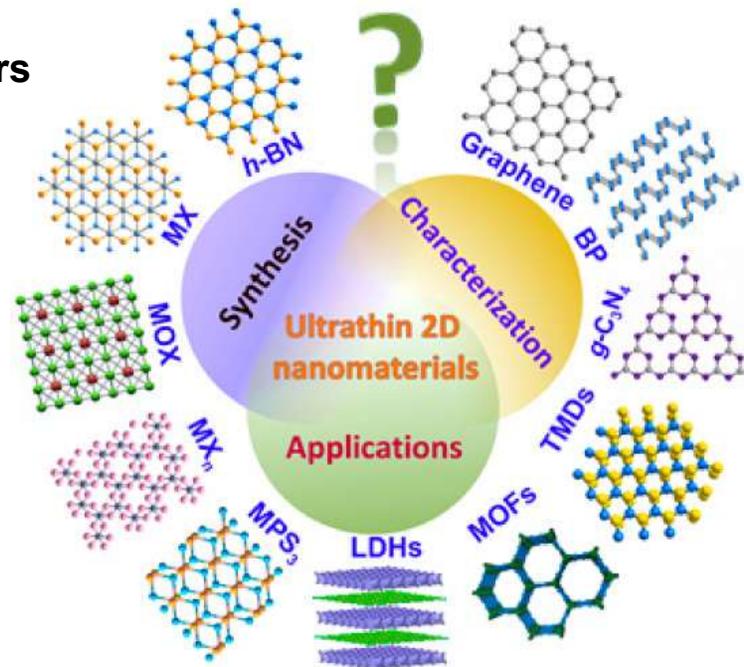
- Absorption coefficient
- Infrared spectroscopy

The emerging of the graphene open a new world in materials science

Thickness is only few nanometers

Important!!!

Layer number



The role of the optical microscope, Raman spectroscopy, and photoluminescence

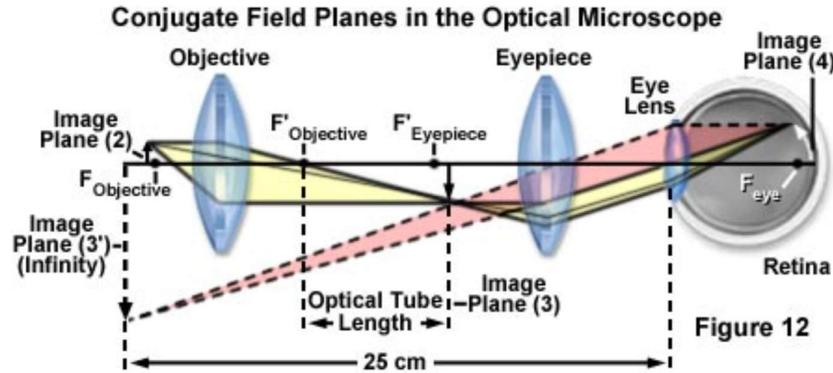
Lots of examples

Various groups of 2D materials

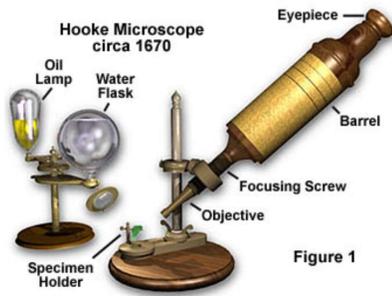
Optical microscope

A? Background-optical microscope

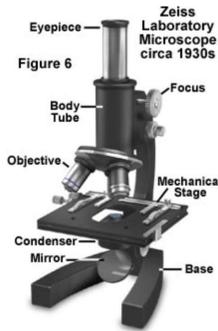
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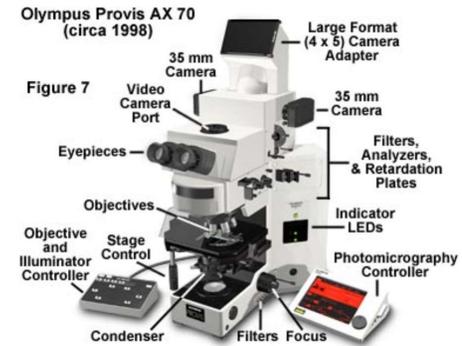
Optical paths



1670



20th century



modern

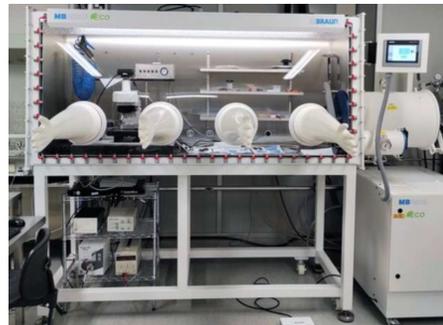
→ More sophisticated

Background-optical microscope



4th floor

There are several
microscopes our group
member used



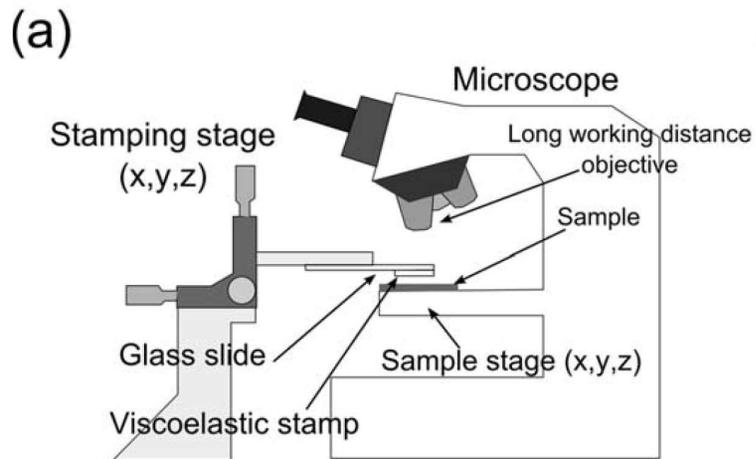
Nanotalo



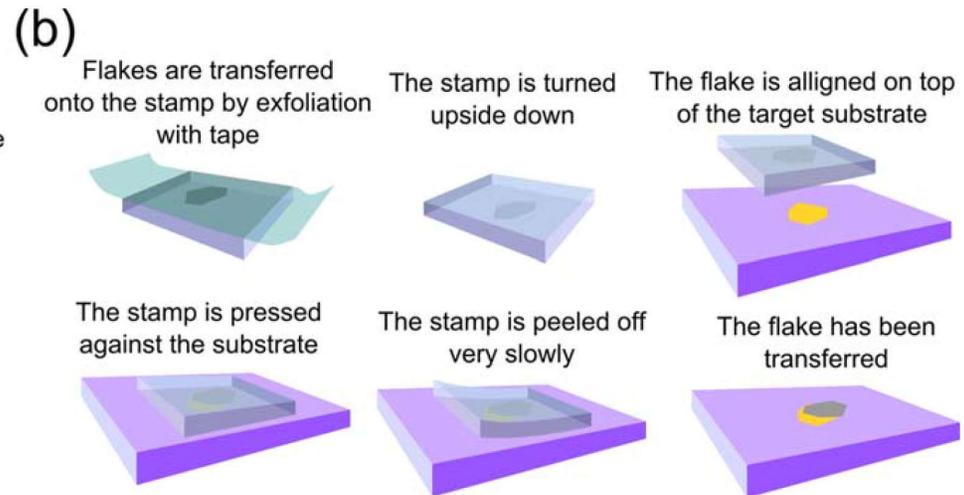
F13 in the cleanroom

A? Optical microscope on 2d materials

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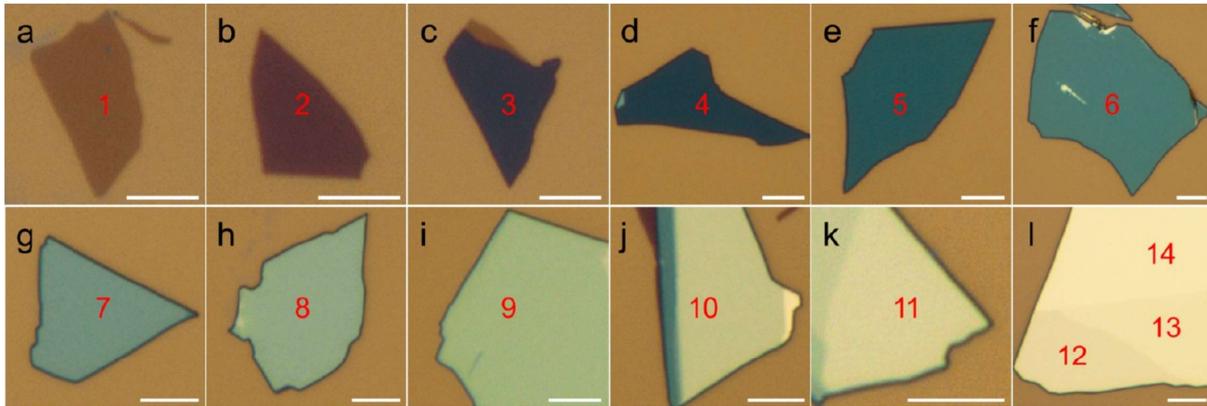
The diagram of the transferring system



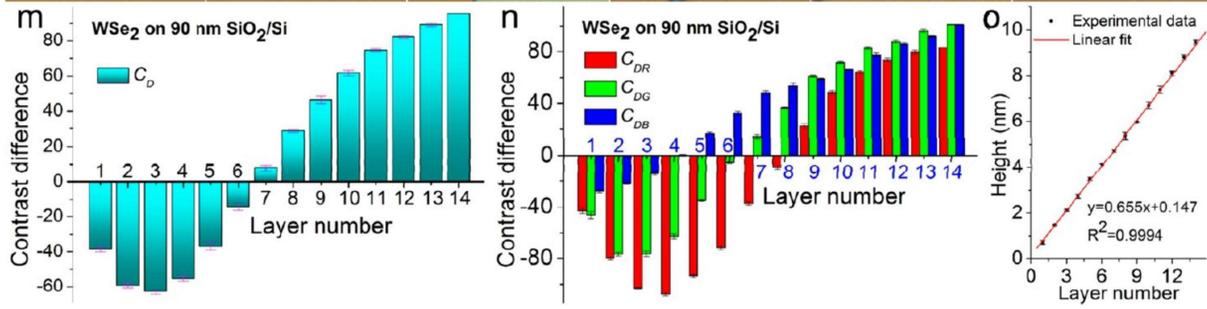
The schematic view of exfoliating 2d materials and stacking them

A? Optical microscope on 2d materials

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$$C(\lambda) = \frac{I_{\text{flake}} - I_{\text{substrate}}}{I_{\text{flake}} + I_{\text{substrate}}}$$

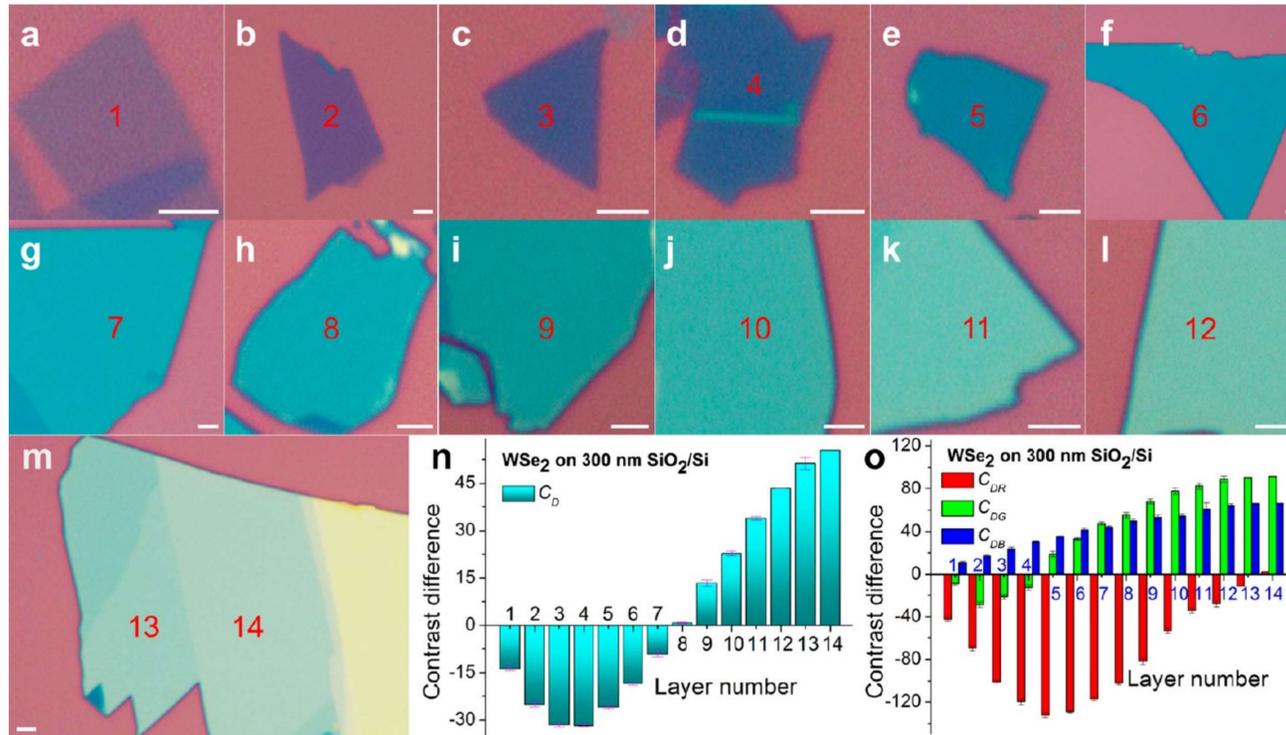


Combining with AFM

A library for quickly identifying the layer number

A? Optical microscope on 2d materials

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Different substrate
300 nm SiO₂/Si

ACS Nano 2013, 7, 11, 10344–10353

A? Optical microscope on 2d materials

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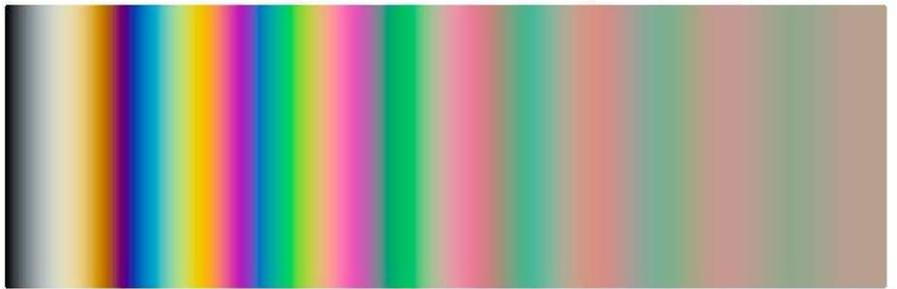
Different thickness with
different color

Why?



The colors of a soap film

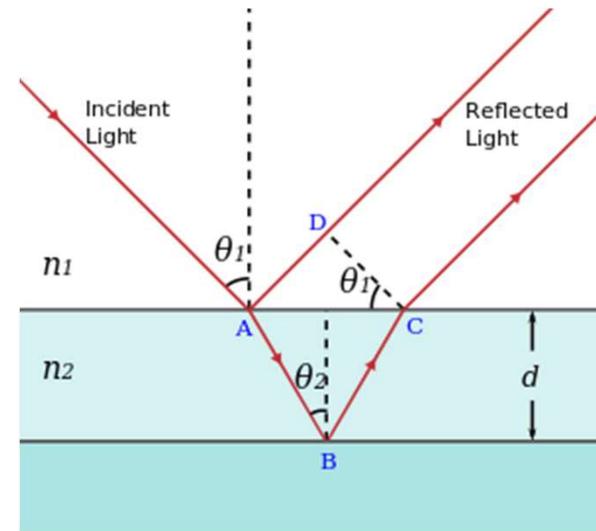
assuming sunlight with normal angle of incidence



0 500 1000 1500

Thickness in nm

© Seifenblasenmann.de

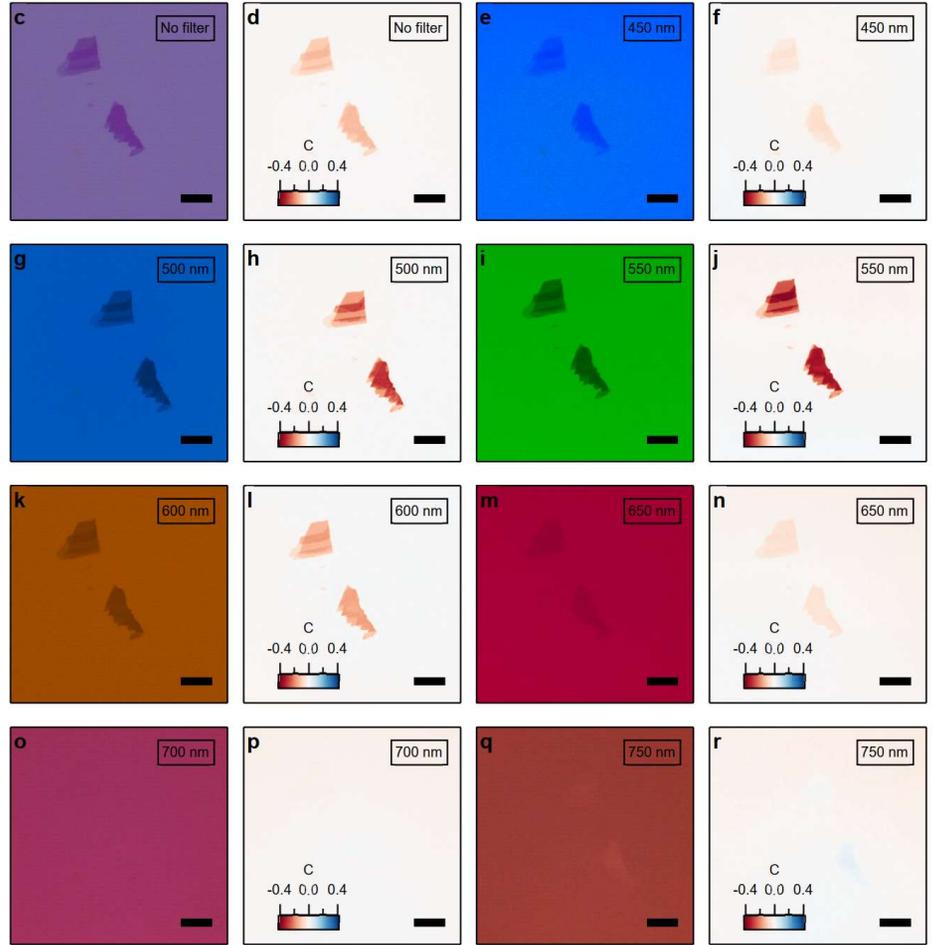
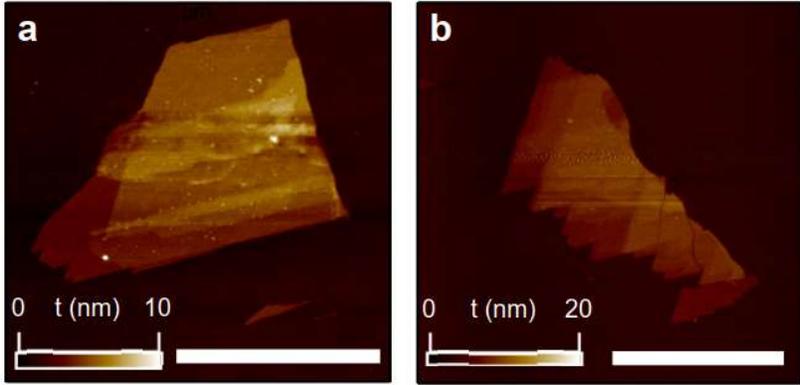


$$2n_2d \cos(\theta_2) = m\lambda$$

Thin-film interference

A? Optical microscope on 2d materials

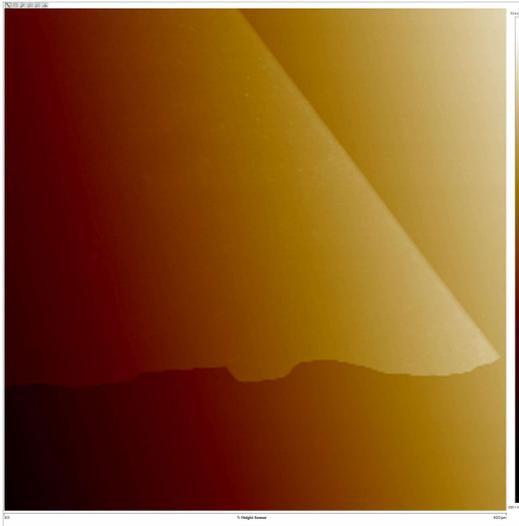
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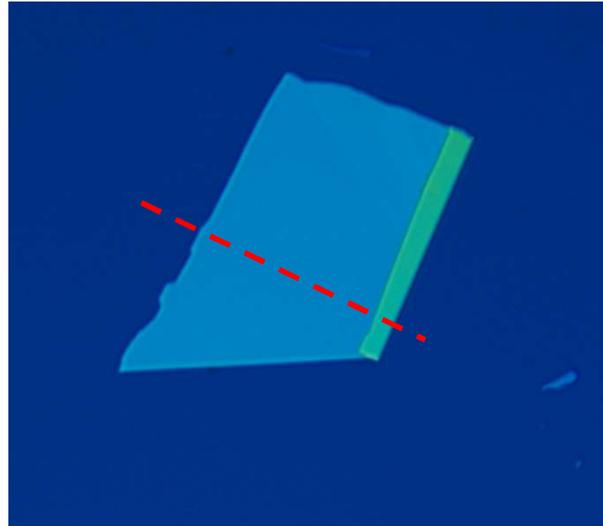
TaS₂

A? Optical microscope on 2d materials

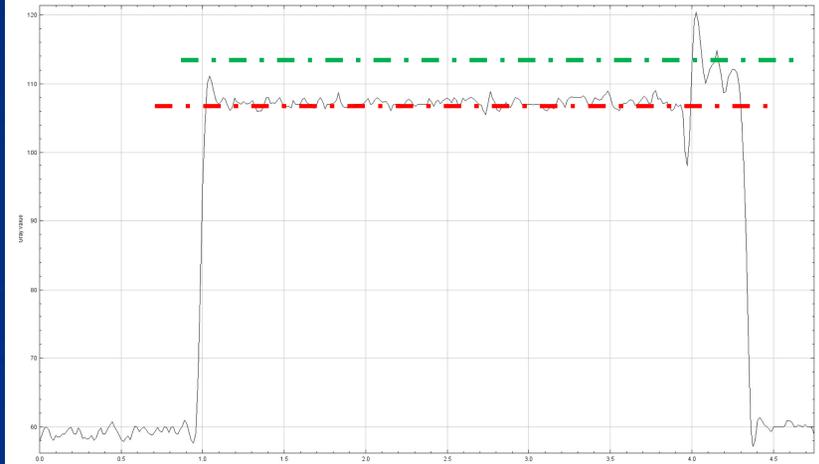
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AFM



Optical images



Optical contrast generated by ImageJ software

A? Optical microscope on 2d materials

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Bubble, cracks can appear during exfoliation.

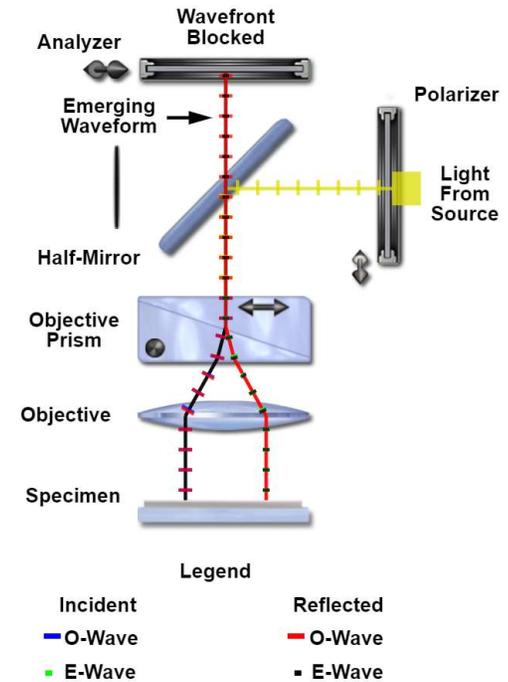
Bad for the performance of devices

Some can not be found by using a bright field mode optical microscope



Can give the information of **hole, bubble, crack**.....

Wavefront Relationships in Reflected Light DIC Microscopy



Differential Interference Contrast

A? Optical microscope on 2d materials

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Bright field mode



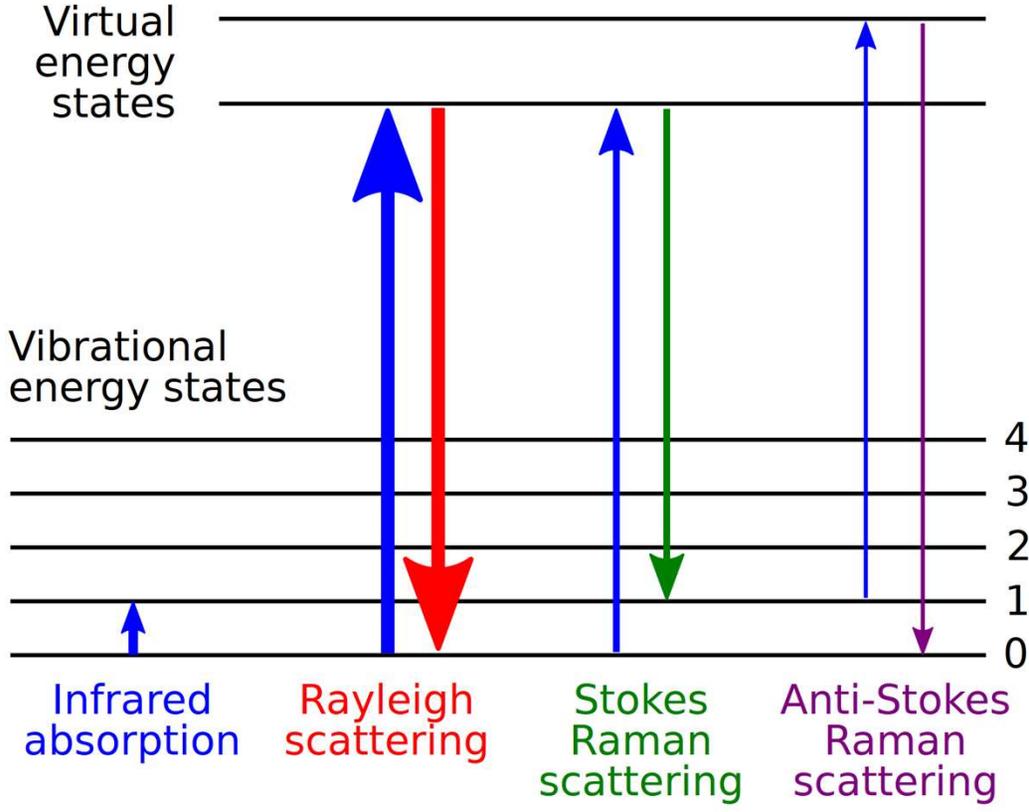
DIC mode

Raman spectroscopy

A? Raman spectroscopy on 2d materials

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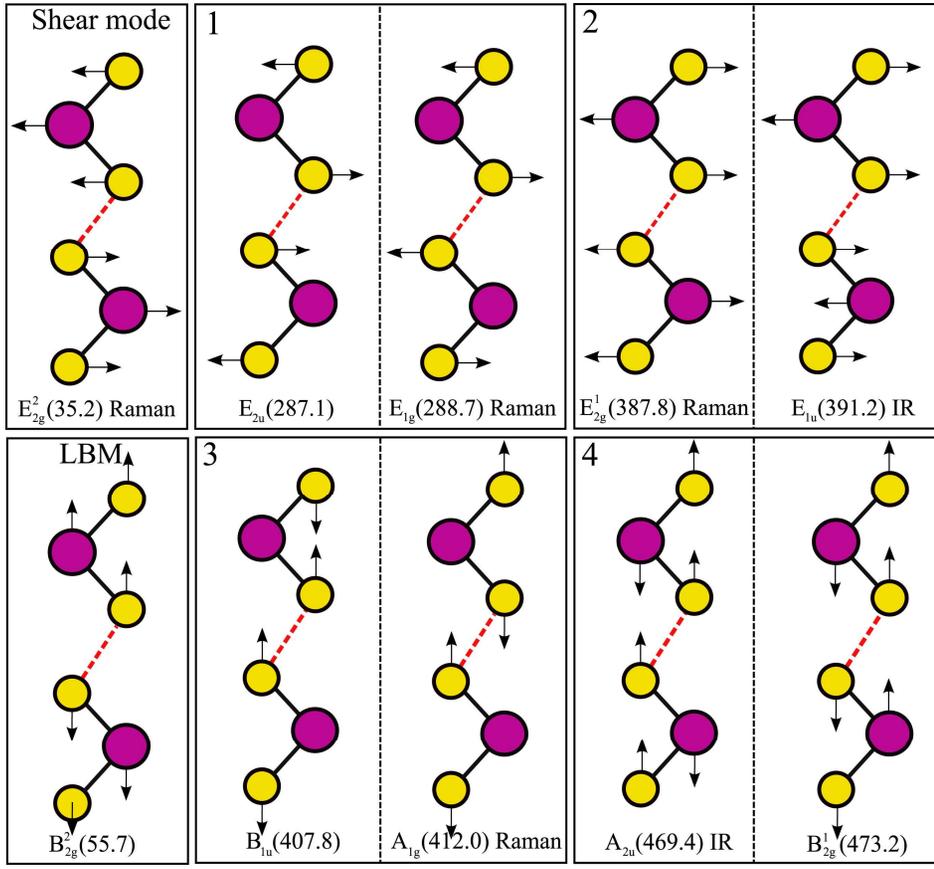
Interaction between light and phonons



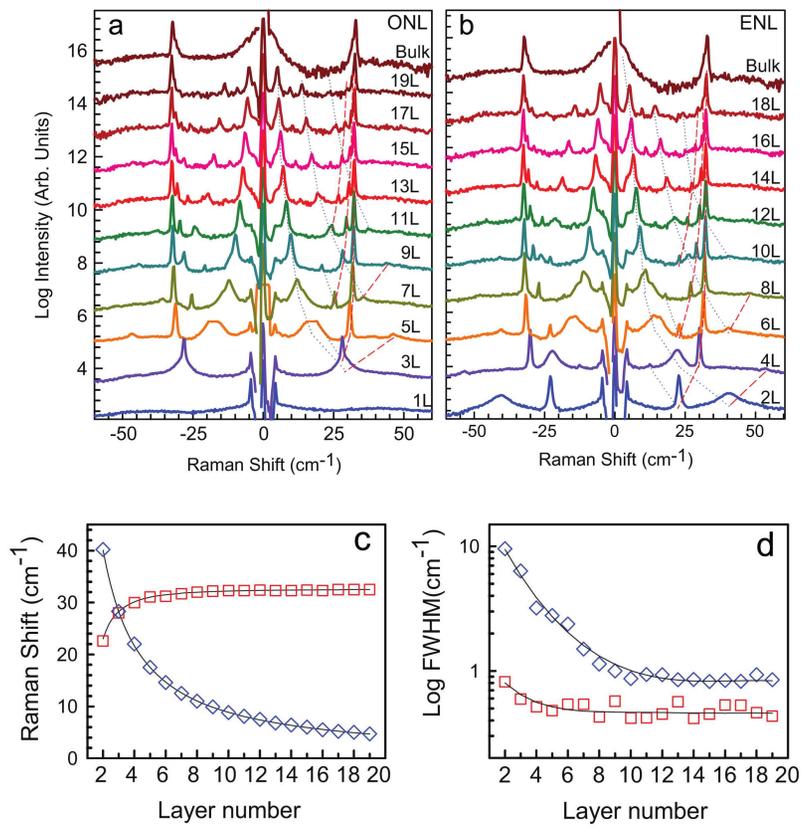
Brief overview of Raman signal

A? Raman spectroscopy on 2d materials

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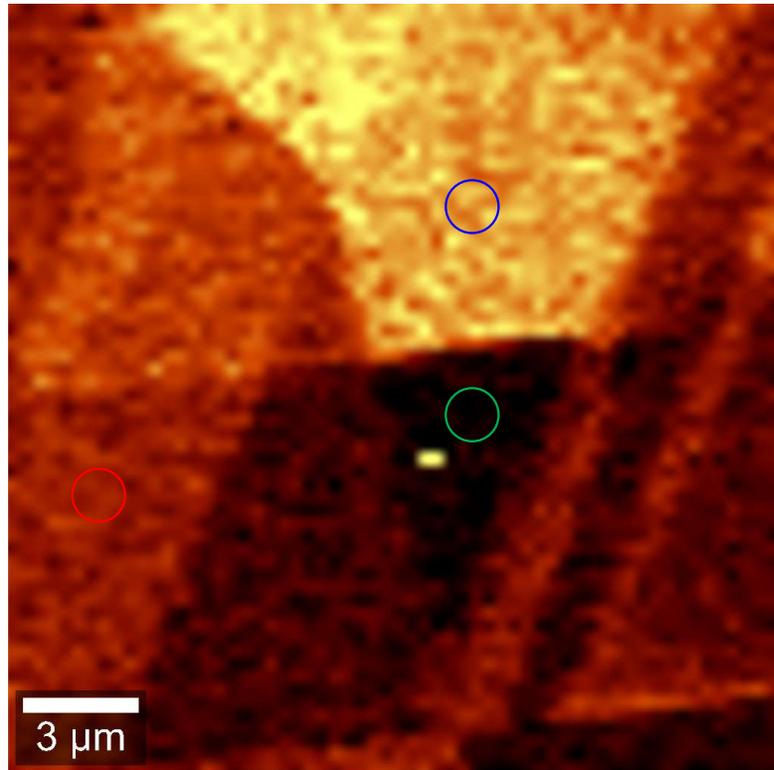
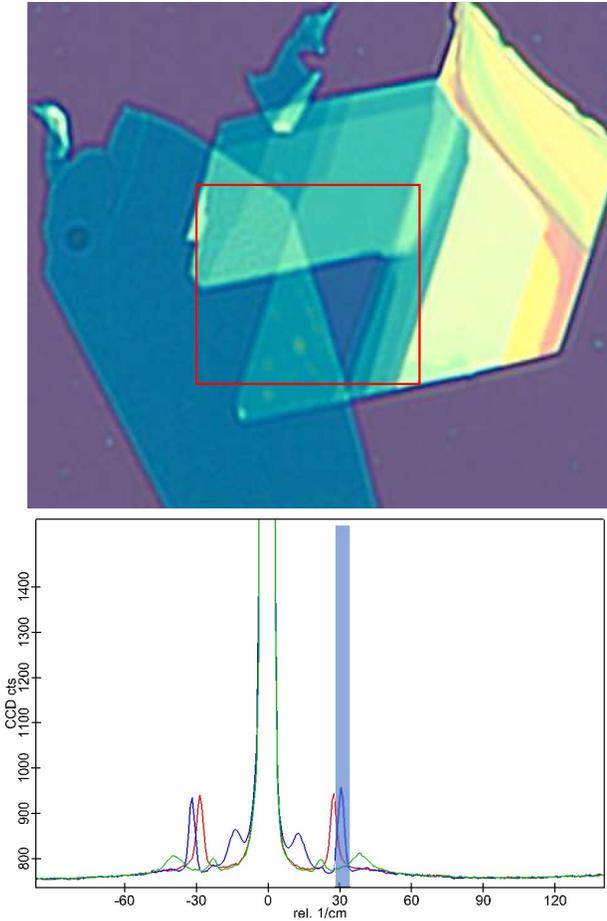
Different phonon modes



<https://doi.org/10.1016/j.surfrep.2015.10.001>

A? Raman spectroscopy on 2d materials

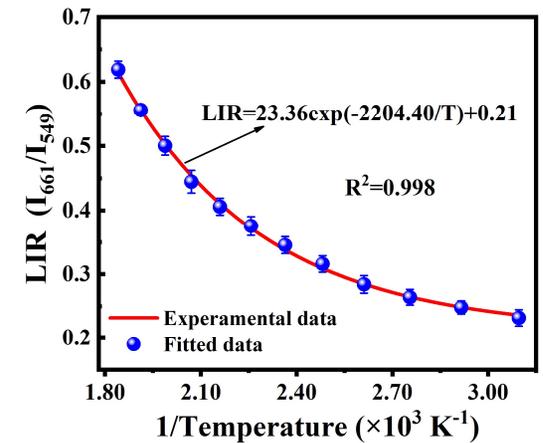
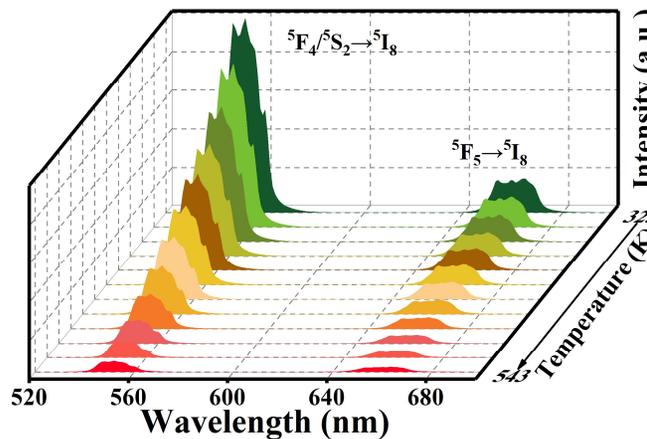
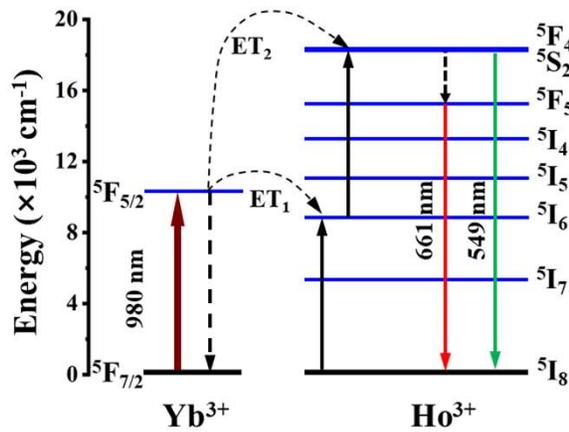
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Photoluminescence (PL)

Light excite electrons to a higher energy level in an atom and then go to lower energy and release the energy by emitting photons

Rare earth ions

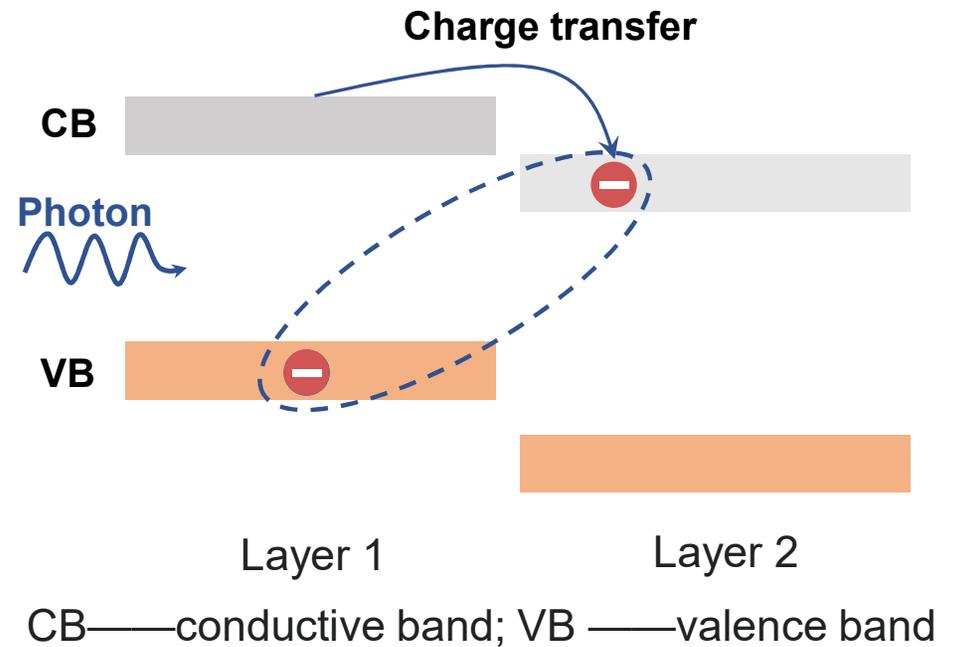
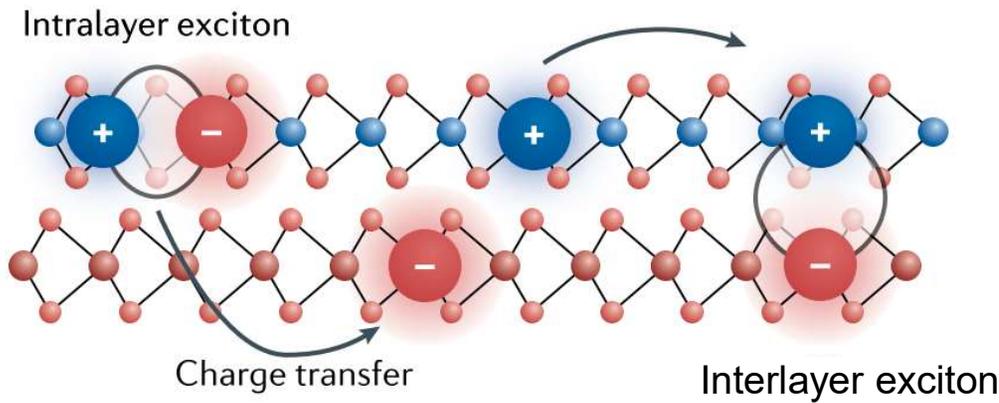


The pathway of upconversion luminescence
ET—energy transfer

Temperature dependence

PL measurement

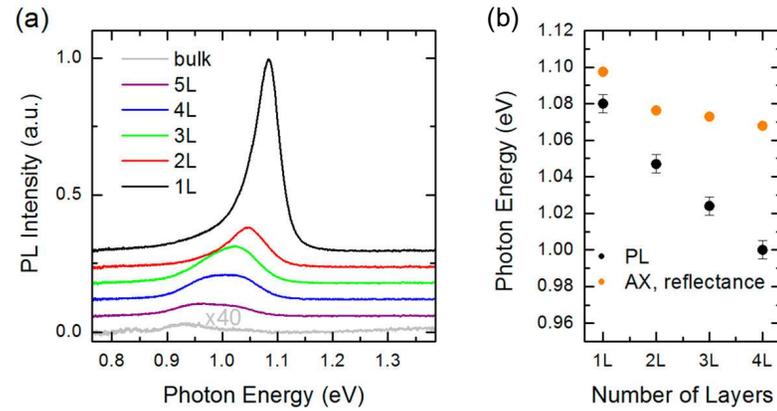
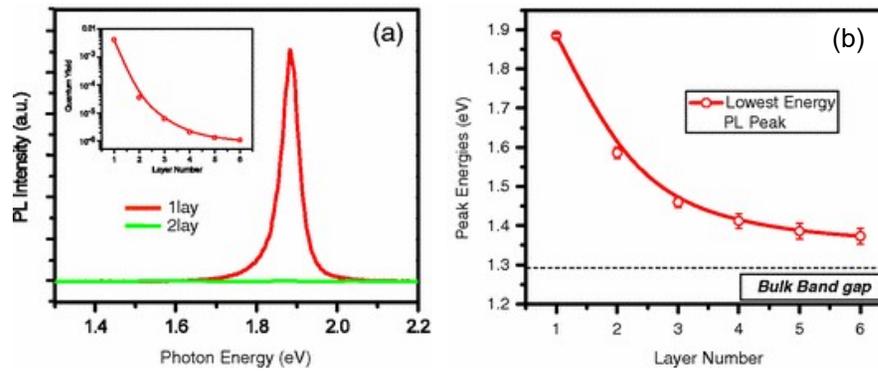
An **exciton** is a bound state of an electron and an electron hole which are attracted to each other by the electrostatic Coulomb force. (From Wikipedia)



A? PL measurement

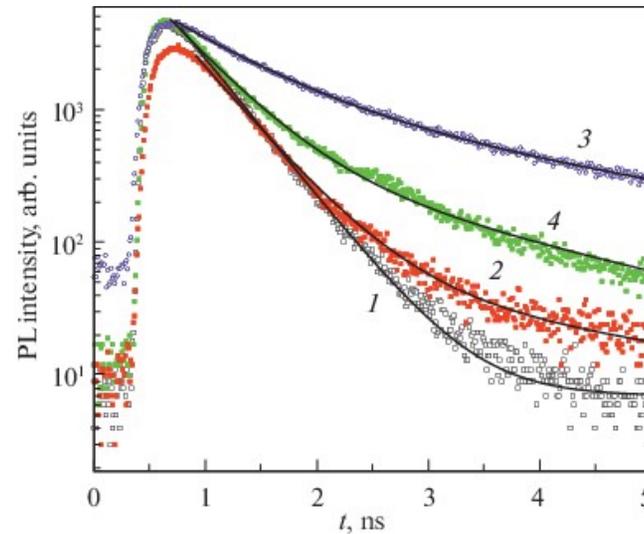
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PL identify the layer number

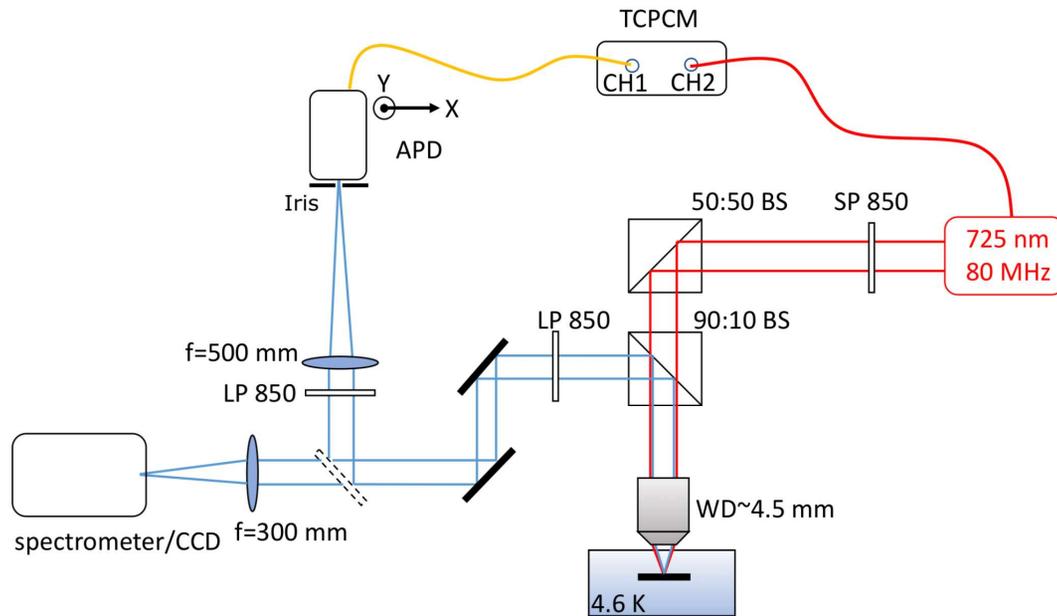


Excitons are demonstrated as a **bridge** between photons and electrons

How to monitor their behavior like electrons
(A, V.....)



Time resolved photoluminescence



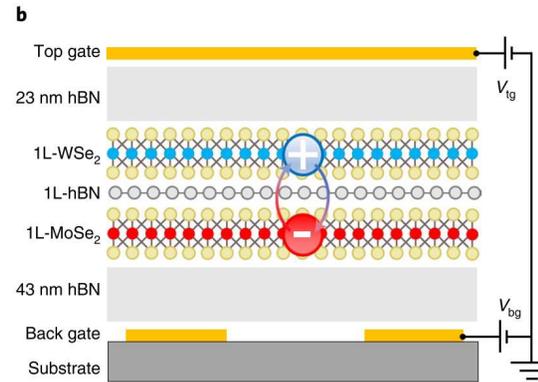
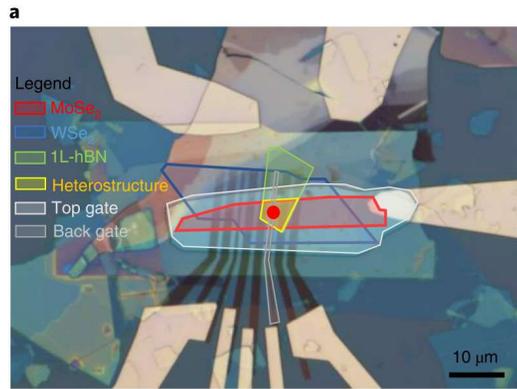
Sketch of the experimental setup. Red lines: excitation laser; blue lines: reflected laser and emitted photons.

TCPCM-Time correlated photon counting module

APD-Avalanche photodiode

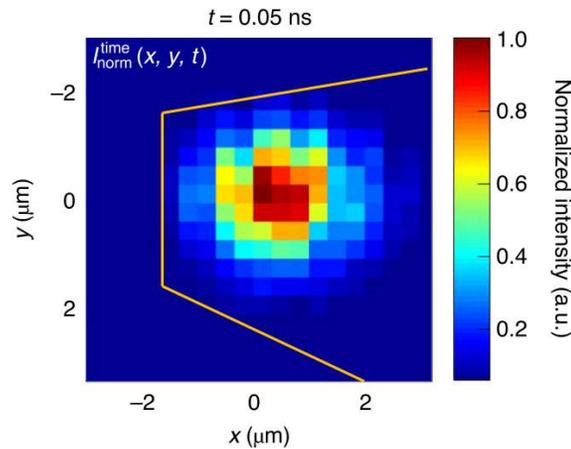
PL measurement

Device structure

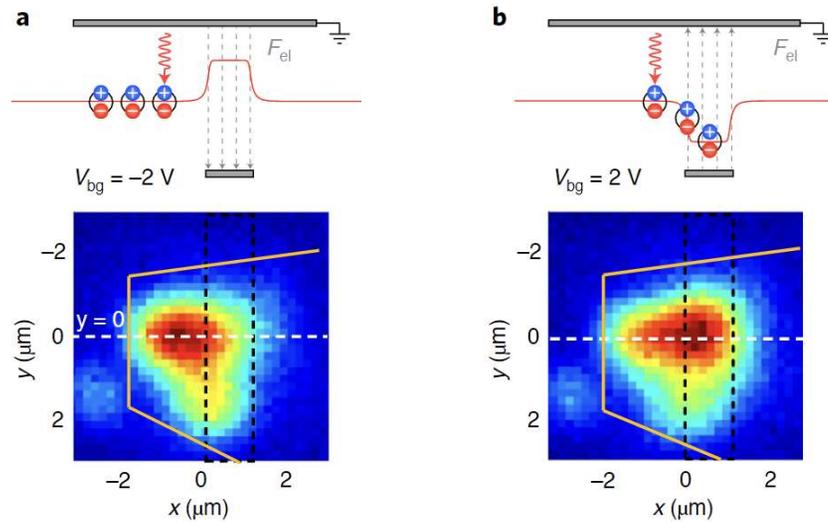


Electron-hole pair recombination

Photoluminescence (PL)

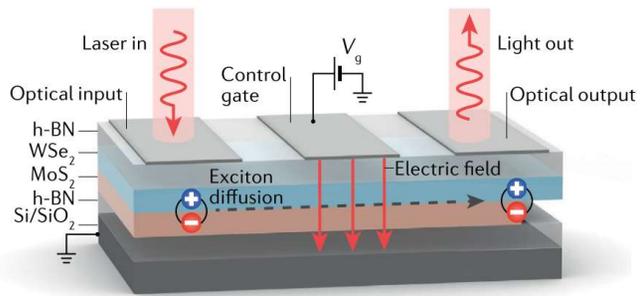


Expansion of an exciton cloud

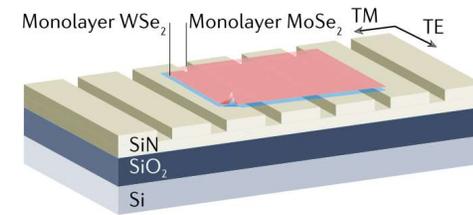
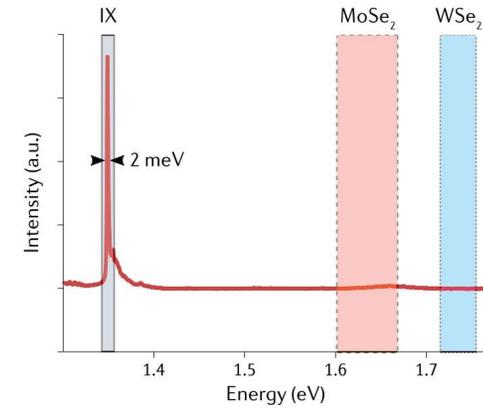
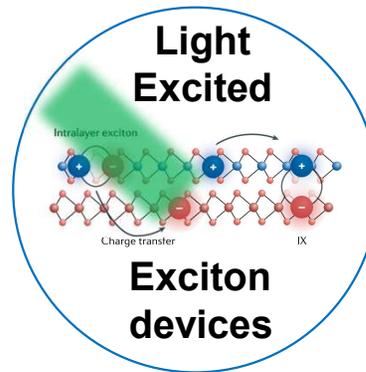


Control of the exciton flux by applying an electric field 27

PL measurement



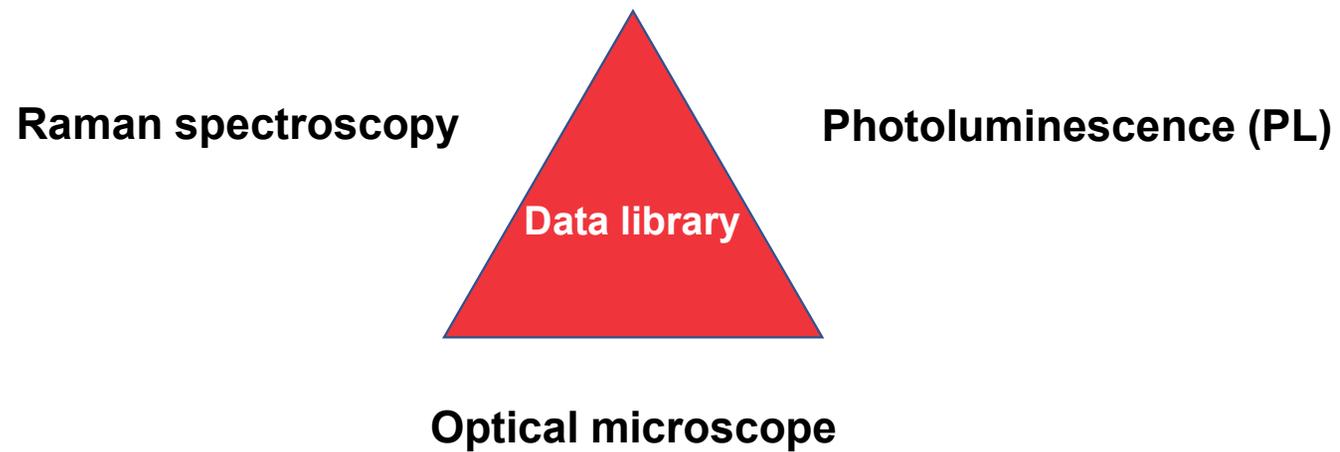
Excitonic Switch and Transistor



Nanolaser



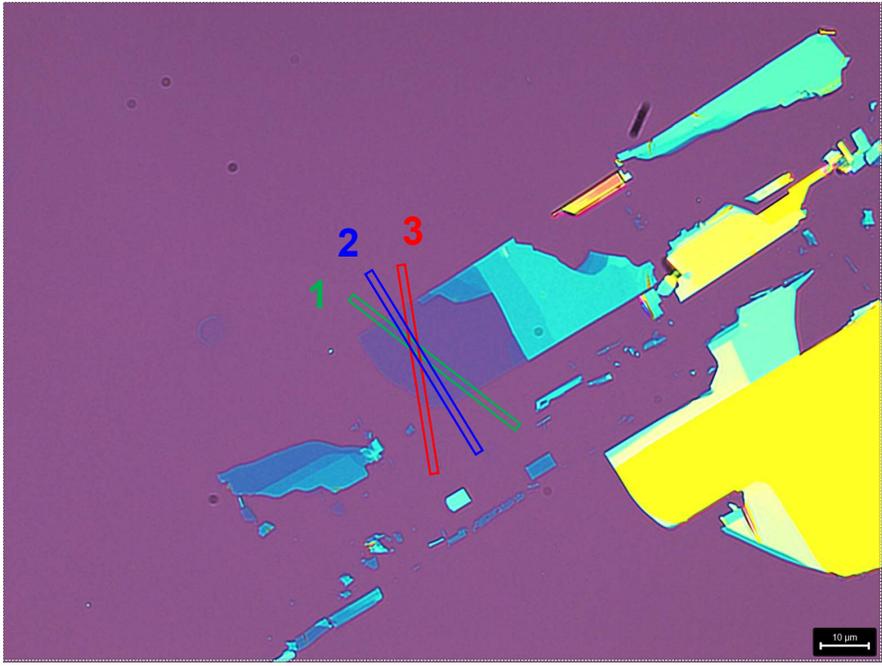
The layer number of the 2D materials can be characterized by several methods



Measurement setup and sources of uncertainty

A? Optical contrast

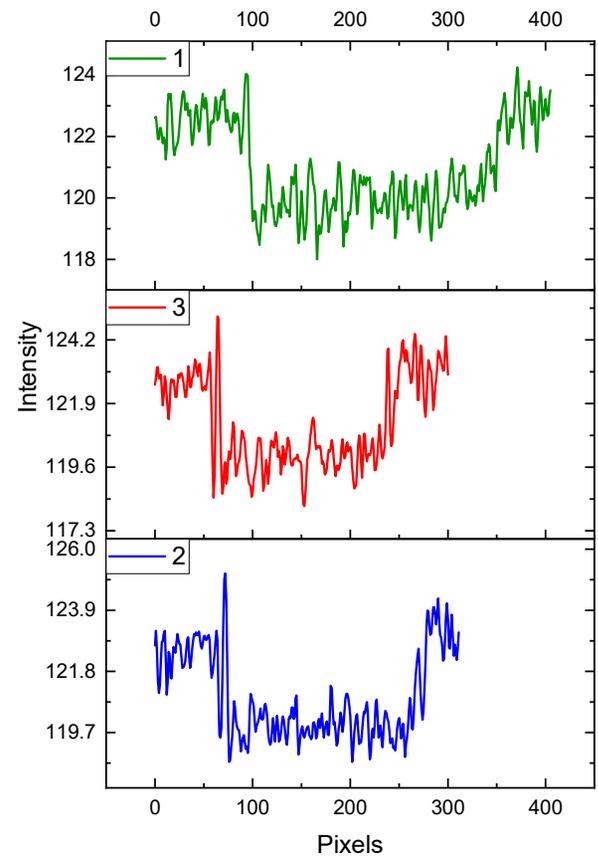
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VOCI

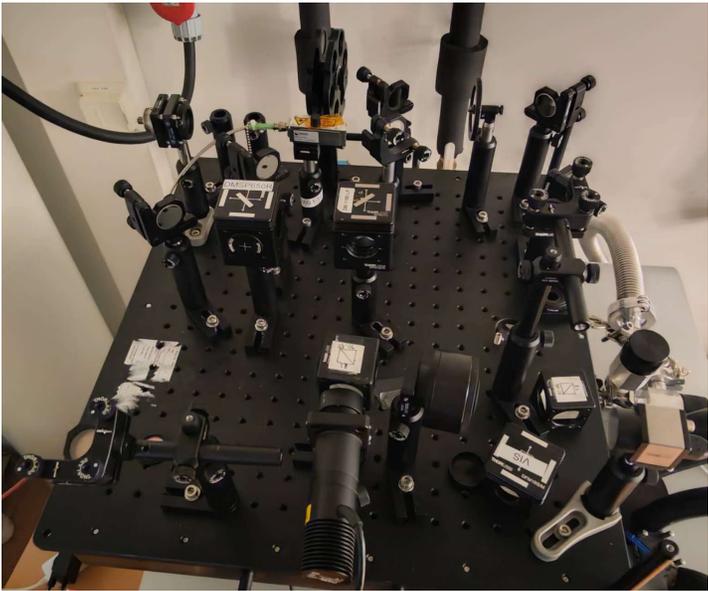
$$C(\lambda) = \frac{I_{\text{flake}} - I_{\text{substrate}}}{I_{\text{flake}} + I_{\text{substrate}}}$$

Optical contrast difference



1	-1,5%
3	-4%
2	-2,62988%

PL measurement



PL measurement setup



Temperature sensor



Powermeter

A? Alignment

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Using a CMOS imaging camera for the quality of the alignment

We do manually

Good alignment

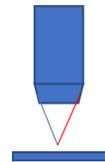
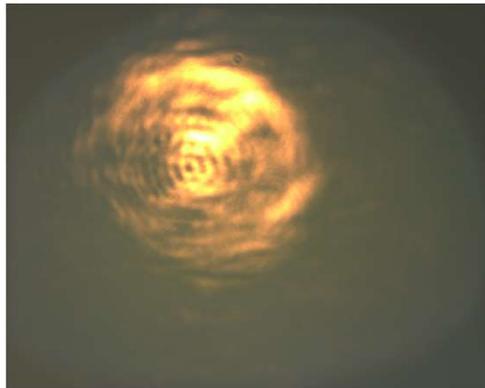
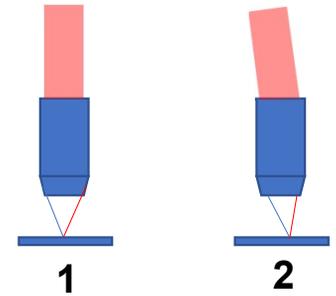
Out of focus



1



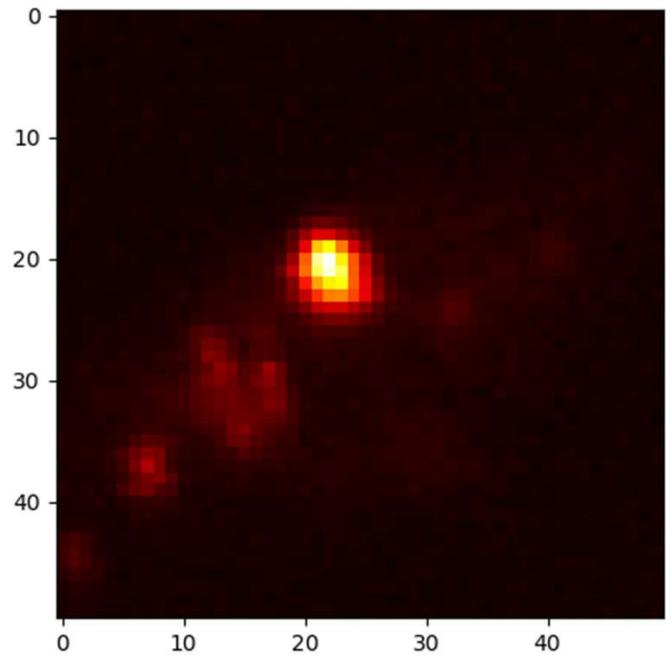
2



A? PL Mapping

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The screenshot shows two windows from the Thorlabs software. The left window is the 'PM320E Data Logger' showing instrument details (PM320E SN M00498487), sensor information (CH1: S130VC SN 18101645, CH2: Photo Diode Input SN not available), and channel settings (Channel 1: 888.90n W, Channel 2: 100.14f W). The right window is the 'ANC350 - Daisy/350 @ ANC350 V1.2.0' control interface, which is divided into three axis control panels (Axis 1, Axis 2, Axis 3). Each axis panel includes fields for Actuator Name, LUT Name, Position (e.g., 1792.856 μm for Axis 1), Automatic Positioning (2500 μm), and Manual Positioning (Single Step, Continuous, Endless) with associated amplitude, frequency, and DC level controls.



Power (nW)	894.33	894.89	893.59	
X (um)	1792.686	1792.193	1791.838	
Y (um)	1272.503	1272.458	1272.652	
Z (um)	2355.908	2356.098	2355.888	

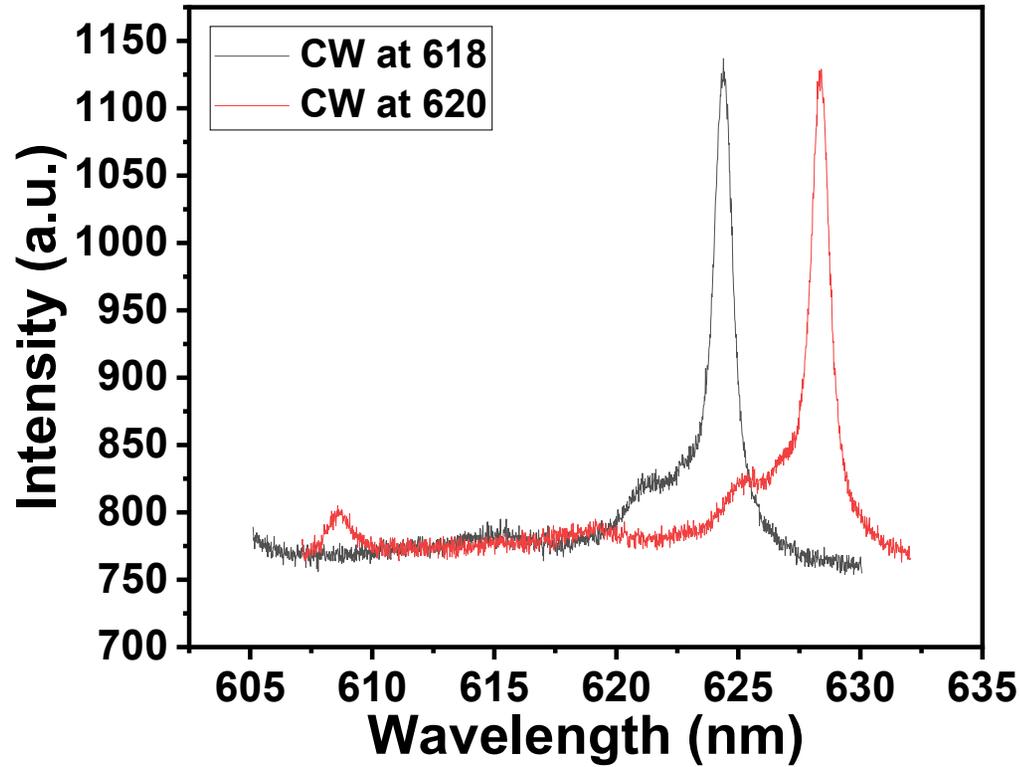
A? Spectrograph without proper calibration

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Not proper calibration

CW: Center wavelength

Spectrograph moved



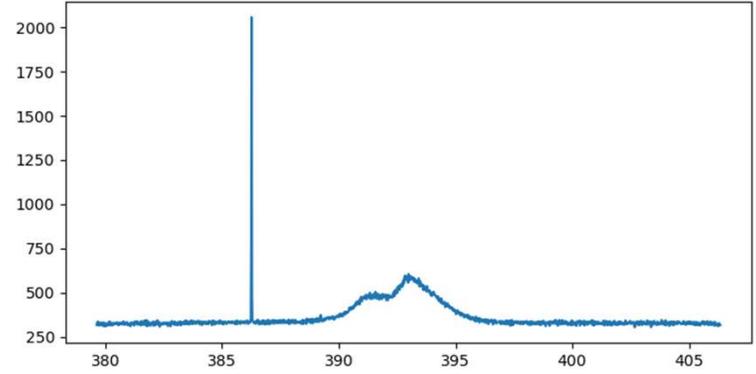
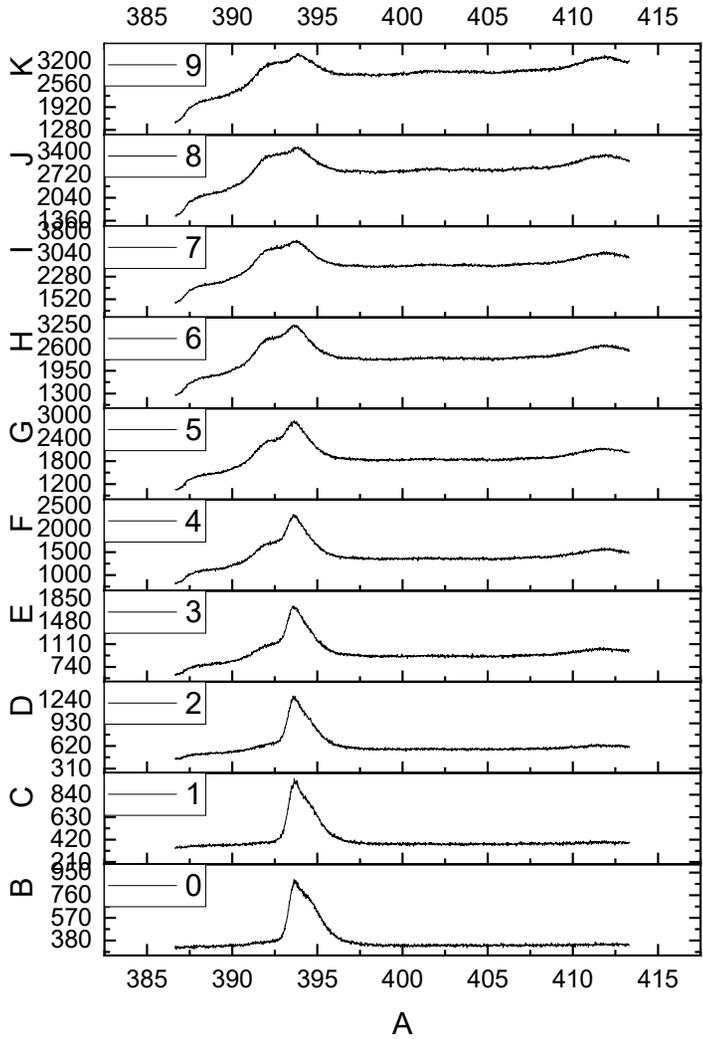
A? Background

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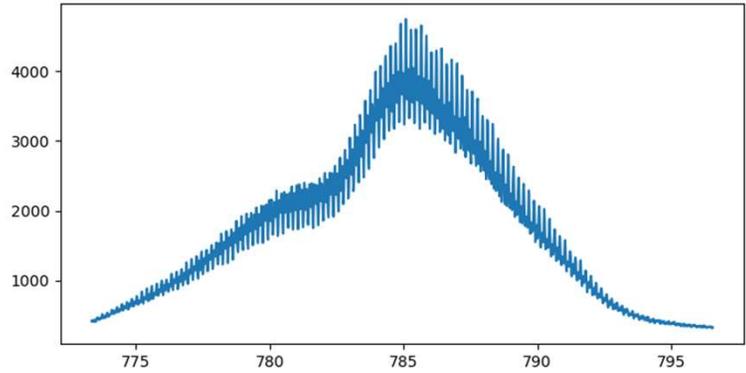
$B \perp (T)$

GaSe

Background



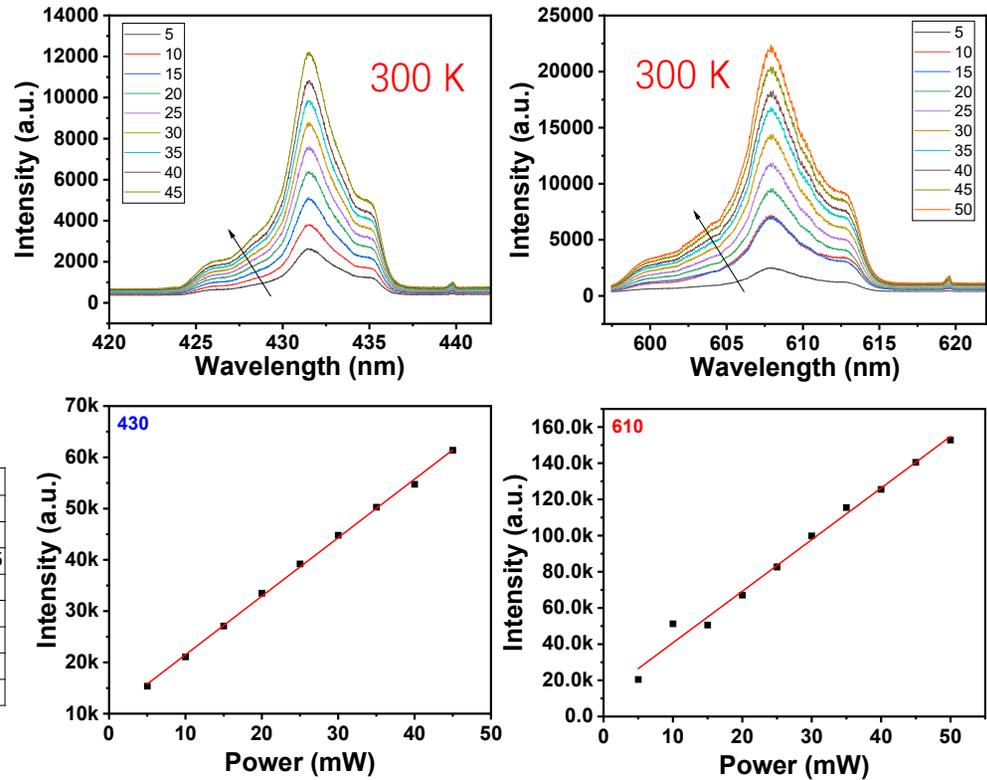
Cosmic radiation



Spectrum of 785 Laser

A? Power dependent emission

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Equation	$y = a + b \cdot x$
Plot	A78550mw1s300_U
Weight	No Weighting
Intercept	$10058.78411 \pm 425.11605$
Slope	1142.36166 ± 15.10902
Residual Sum of Squares	2396966.37717
Pearson's r	0.99939
R-Square (COD)	0.99878
Adj. R-Square	0.9986

Equation	$y = a + b \cdot x$
Plot	A78550mw1s300_W@2
Weight	No Weighting
Intercept	$12225.69148 \pm 3355.03229$
Slope	2851.12344 ± 108.14248
Residual Sum of Squares	1.92964E8
Pearson's r	0.99429
R-Square (COD)	0.98862
Adj. R-Square	0.9872

[Anatomy of a Microscope | Microscopy Primer | Olympus LS \(olympus-lifescience.com\)](#)

<https://wiki.aalto.fi/display/SSC/Raman+Spectroscopy>

<https://www.microscopyu.com/tutorials/wavefront-relationships-in-reflected-light-dic-microscopy>